INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

March 26, 2026

IGI Report Number	LG784606483
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.66 - 7.72 X 4.62 MM

GRADING RESULTS

Carat Weight	1.70 CARAT
Color Grade	D
Clarity Grade	VVS 1
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

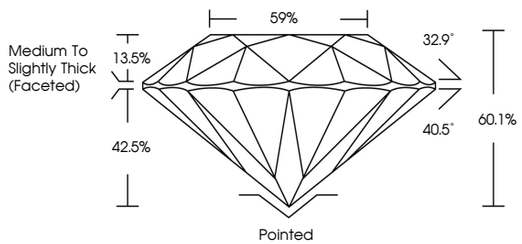
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG784606483

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG784606483

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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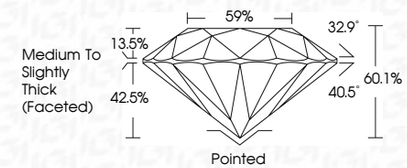

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IGI

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ROUND BRILLIANT
7.66 - 7.72 X 4.62 MM

Carat Weight	1.70 CARAT
Color Grade	D
Clarity Grade	VVS 1
Cut Grade	EXCELLENT
Depth	60.1%
Table	59%
Girdle	Medium To Slightly Thick (Faceted)
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG784606483

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